

AF/2800
PATENT

Case Docket No. ASMMC.036AUS

Date: May 19, 2003

Page 1

Applicant : Sophie et al.
Appl. No. : 09/975,466
Filed : October 9, 2001
For : IN SITU REDUCTION OF
COPPER OXIDE PRIOR TO
SILICON CARBIDE
DEPOSITION
Examiner : Kielin, E.
Art Unit : 2813

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May 19, 2003

(Date)

Andrew N. Merickel, Reg. No. 53,317

COMMISSIONER FOR PATENTS MAIL STOP AF
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

(X) Amendment and Request for Reconsideration in 7 pages.

The fee has been calculated as shown below:

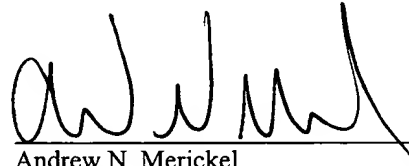
CLAIMS AS FILED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	21	—	32	= 0 ×	\$18	= \$0
Independent Claims	2	—	4	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add					\$280	= \$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0

(X) An Information Disclosure Statement.

(X) A PTO Form 1449 with 3 references.

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- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.
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